

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

(Use several sheets if necessary)

Attorney Docket No.:
8014-1195

Application No.: **NEW NATIONAL PHASE**

Applicant:
Takeshi NAKATA et al

Filing Date:

Group Art Unit:

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

I. Watanabe et al., 'A New Planar-Structure InAlGaAs-InAlAs Superlattice Avalanche Photodiode with a Ti-Implanted Guard-Ring', *IEEE Photonics Technology Letters*, 1996, vol.8, No.6, pages 827 to 829

EXAMINER: /Benjamin Tzu-Hung Liu/

DATE CONSIDERED

07/24/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

* English language abstract provided for the Examiner's convenience.

X&T August 10, 2008

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH /BT/